Form 1449 (Modified)

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Applicant:

WU et al.

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Examiner		_				Sub-	Filing
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Foreign Patent or Published Foreign Patent Application

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Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
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Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
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Examiner. Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.